

Waveguiding in Mathieu photonic lattices

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Abstract: We exploit single Mathieu beams (MB) as lattice-writing light to fabricate discrete waveguide structures and investigate their nonlinear self-action in these structures, leading to morphing discrete diffraction. Nonlinear self-action of elliptic MB in SBN breaks this sensitive equilibrium and we demonstrated a new type of rotating beam formation arises with high-intensity filaments corresponding to the energy flow in an enforced preferential direction. This process is beneficially applied to realize chiral twisted photonic refractive index structures with a tunable ellipticity.

Experimental setup for investigation of single and Elliptic MB

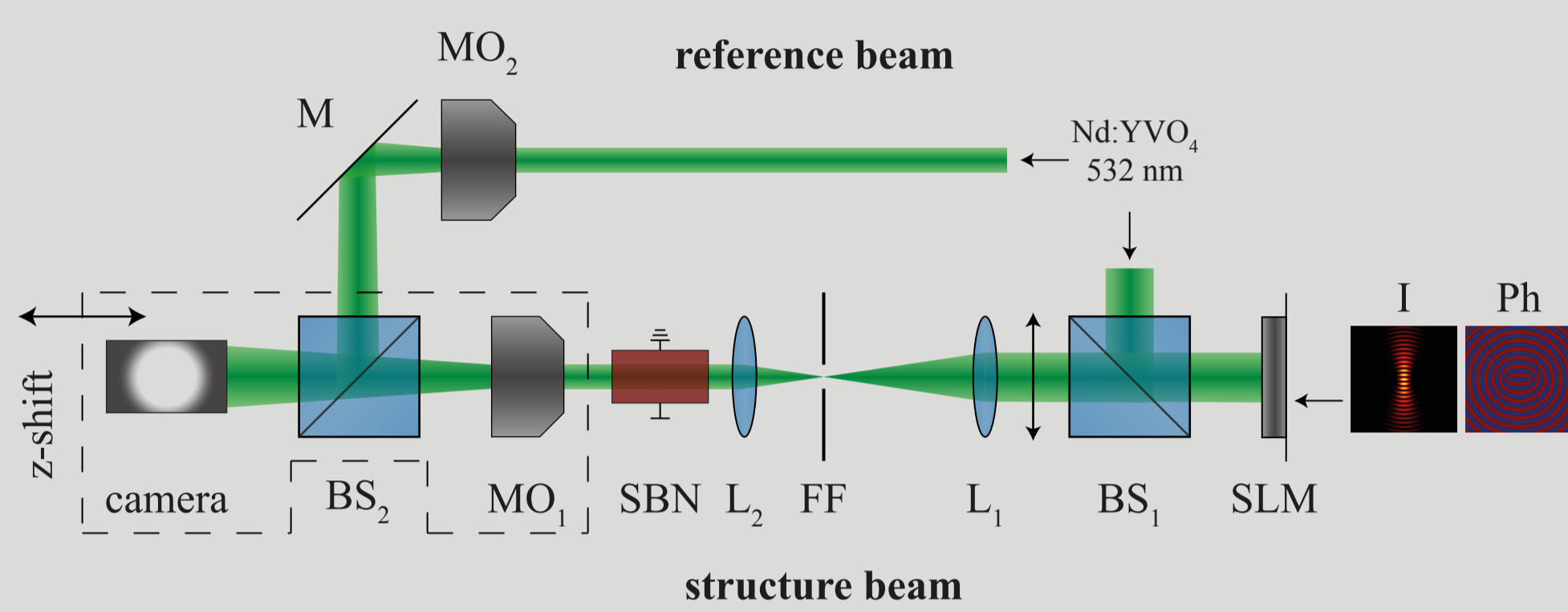


Fig. 1. Setup scheme for optical induction in a photorefractive SBN crystal: BS: beam splitter, FF: Fourier filter, L: lens, M: mirror, MO: microscope objective, SLM: spatial light modulator.

Theoretical model

Nonlinear light propagation in photonic structures is simulated by numerically solving the nonlinear Schrödinger equation:

$$i\partial_z A(r) + \frac{1}{2}\Delta_{\perp} A(r) + \frac{1}{2}\Gamma E(A(r)^2)A(r) = 0$$

Owing to the biased SBN crystal, we use an **anisotropic approximation** to calculate the refractive index modulation and solve the potential equation:

$$\Delta\Phi_{sc} + \nabla\Phi_{sc} \nabla \ln(1+I) = E_{ext} \partial_x \ln(1+I)$$

Even E_m and Odd O_m MB are mathematically described as a product of radial ce_m, se_m and angular Je_m, Jo_m Mathieu functions of order m :

$$E_m(\xi, \eta; q) = C_m(q) Je_m(\xi; q) ce_m(\eta; q)$$

$$O_m(\xi, \eta; q) = S_m(q) Jo_m(\xi; q) se_m(\eta; q)$$

where $q = f^2 k_t^2 / 4$ is parameter of ellipticity, $k_t = 2\pi/a$ is transverse wave number and a is the characteristic structure size. **Elliptic MB** $A_m(\xi, \eta)$ are mathematically described as a complex linear superposition of even and odd MB of the same order m :

$$A_m = E_m + iO_m$$

Experimental characterization of a 0th order lattices fabricating even MB

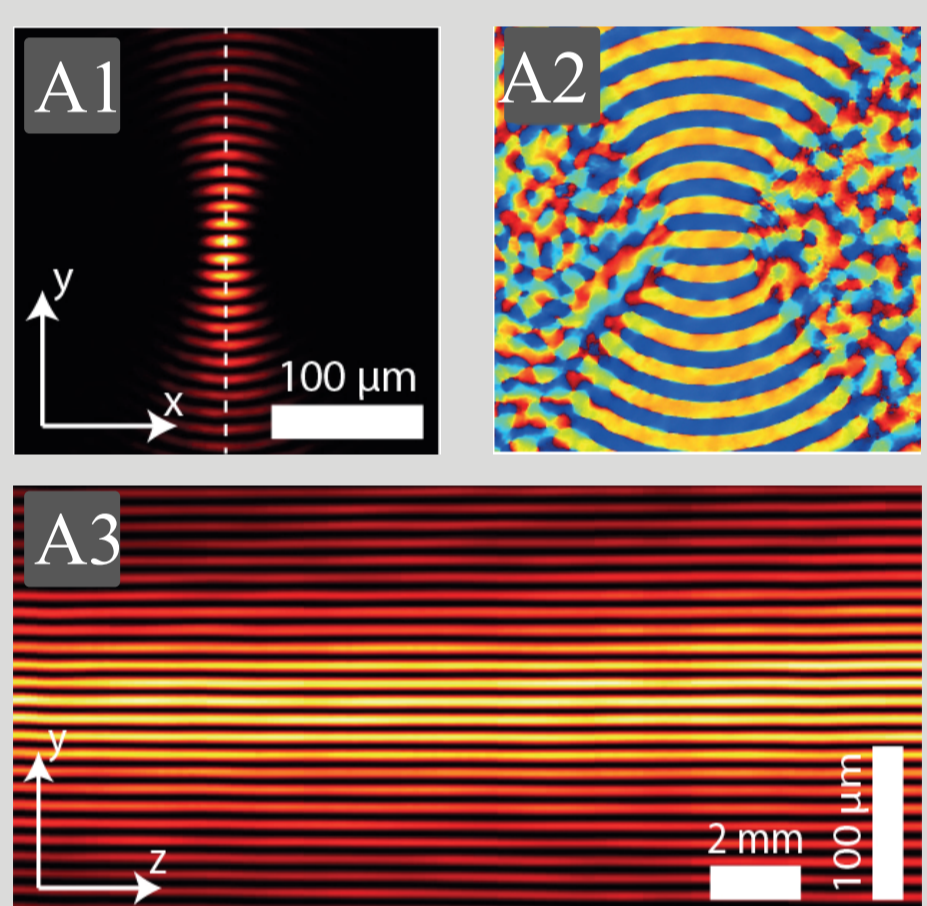


Fig. 2. Transverse intensity (A1) and phase (A2) distributions, (A3) linear yz cross-section through the intensity volume (A1) in SBN crystal 15mm long.

Morphing diffraction of MB with transition from 1D to 2D

1D discrete diffraction

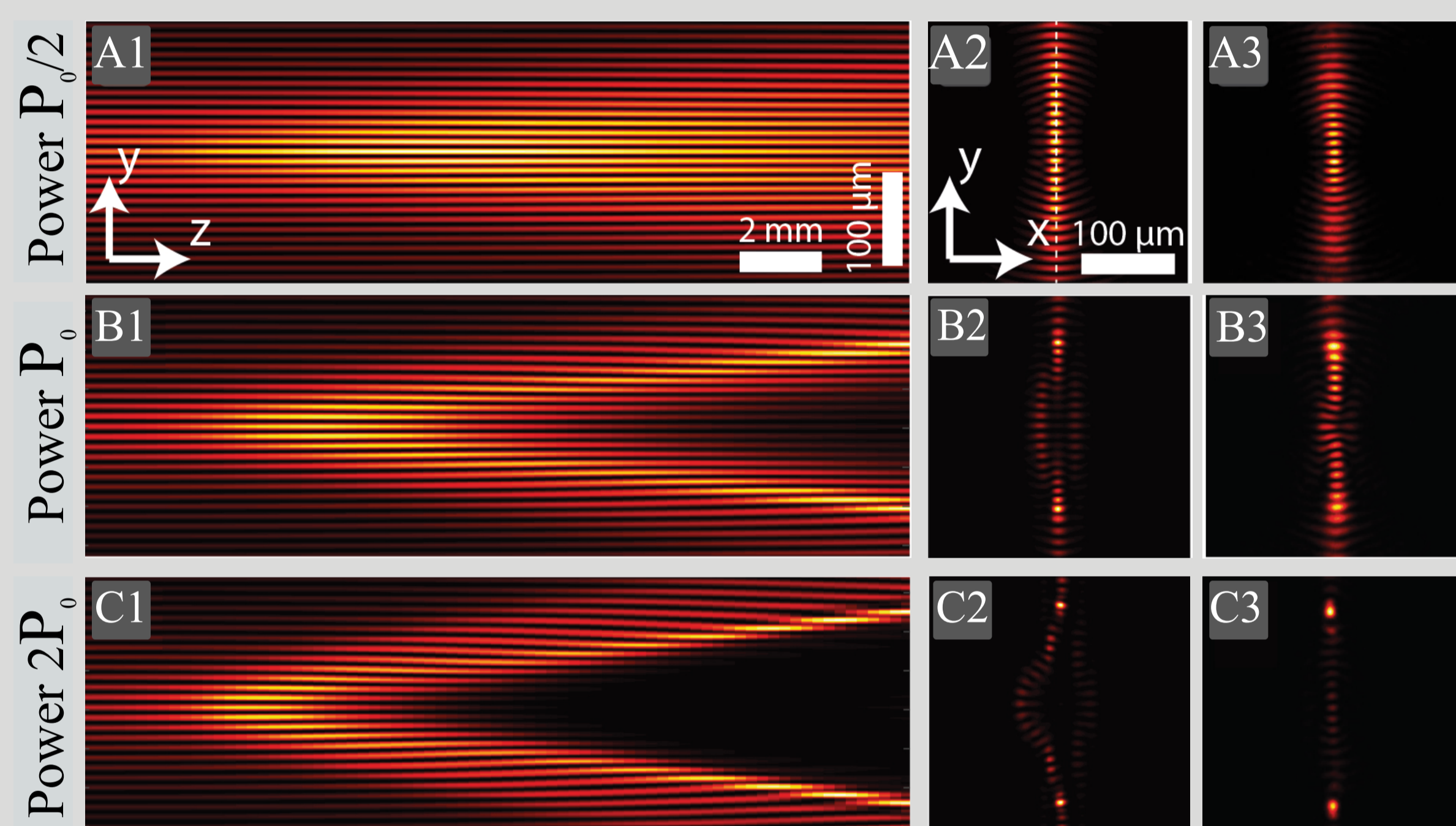


Fig. 3. Nonlinear propagation of even **0th-order MB** ($q=25$) in SBN crystal, nonlinearly inscribed with increasing beam powers ($P_0=20\mu\text{W}$).

discrete diffraction along curved 2D path

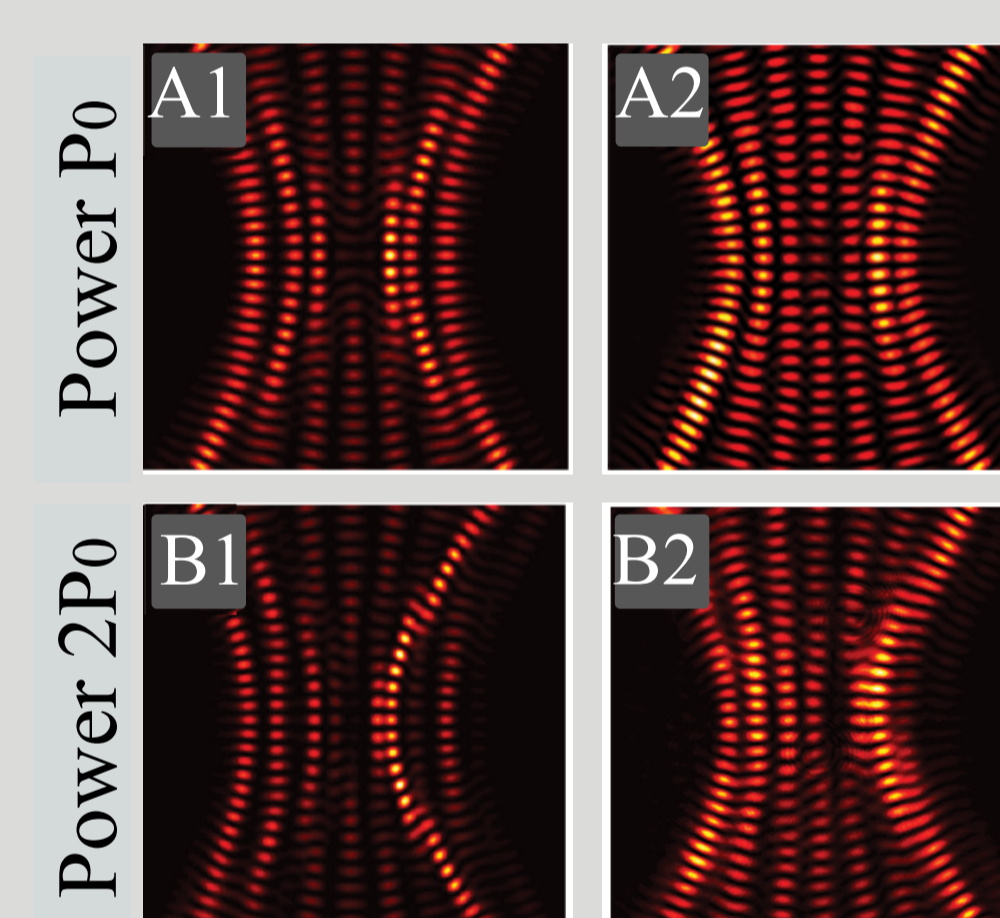


Fig. 4. Nonlinear propagation of even **6th-order MB** ($q=325$) in SBN crystal, nonlinearly inscribed with increasing beam powers ($P_0=20\mu\text{W}$).

Linear propagation of the narrow Gaussian probe beam in Mathieu lattices

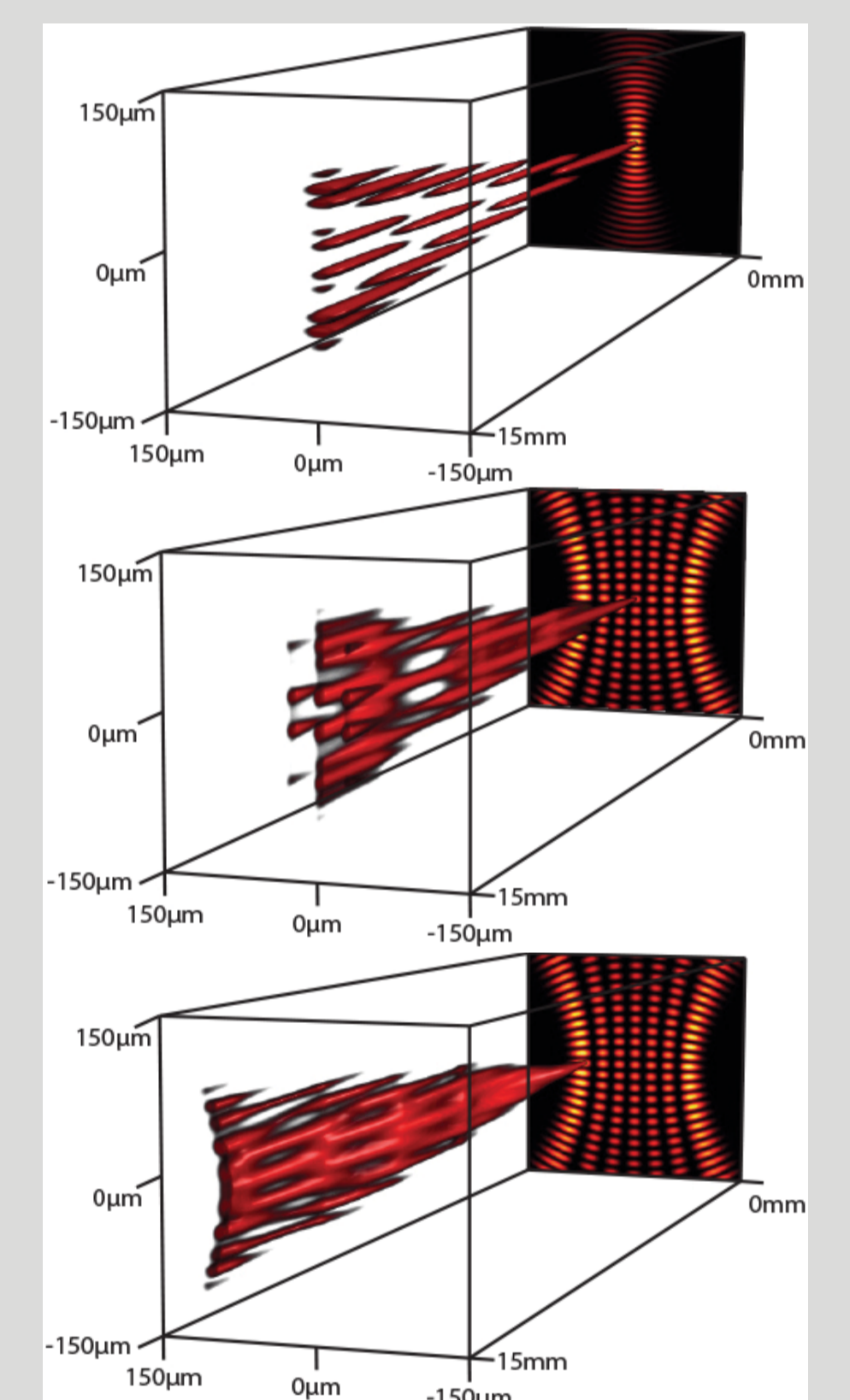


Fig. 5. Intensity distribution of a Gaussian probe beam inside the Mathieu lattices.

Characterization of Elliptic MB

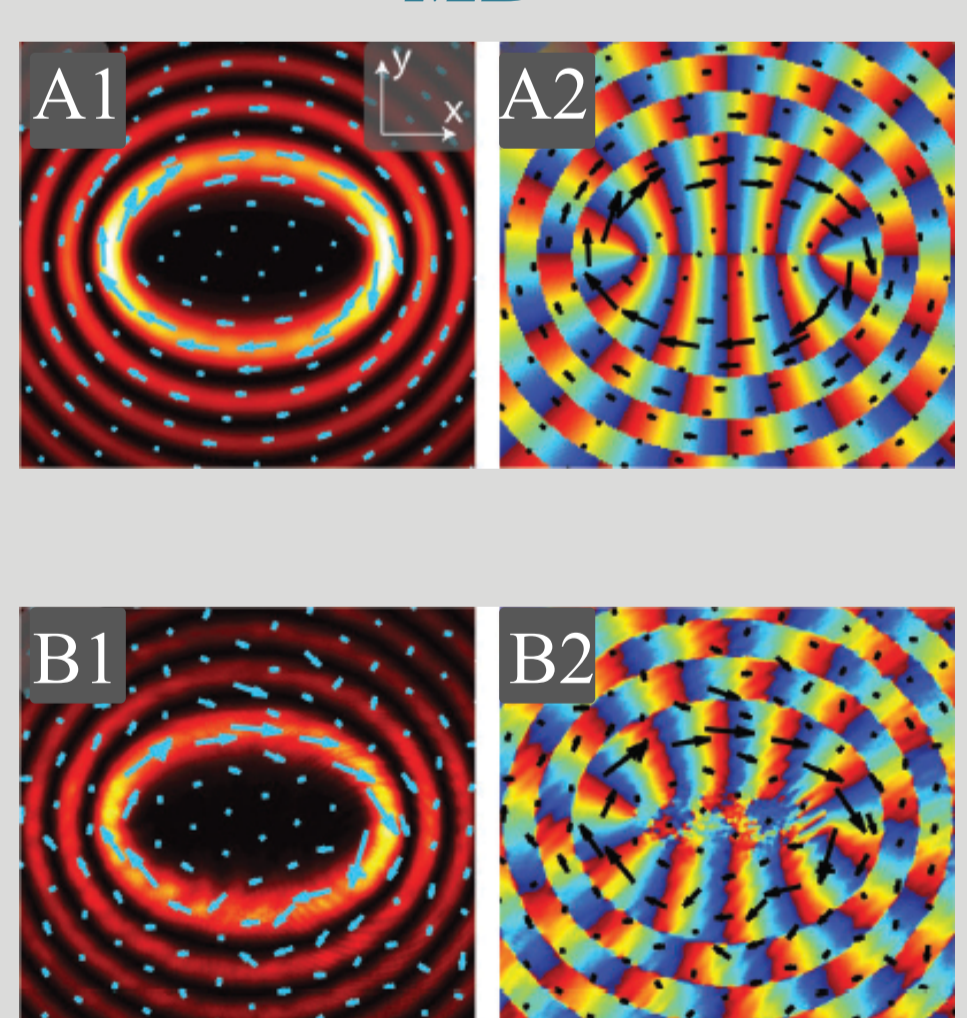


Fig. 6. Elliptic MB of order $m=10$ with an ellipticity of $q=25$. Arrows indicate the **Pointing vector**.

Tailored, Nonlinear Mathieu lattices

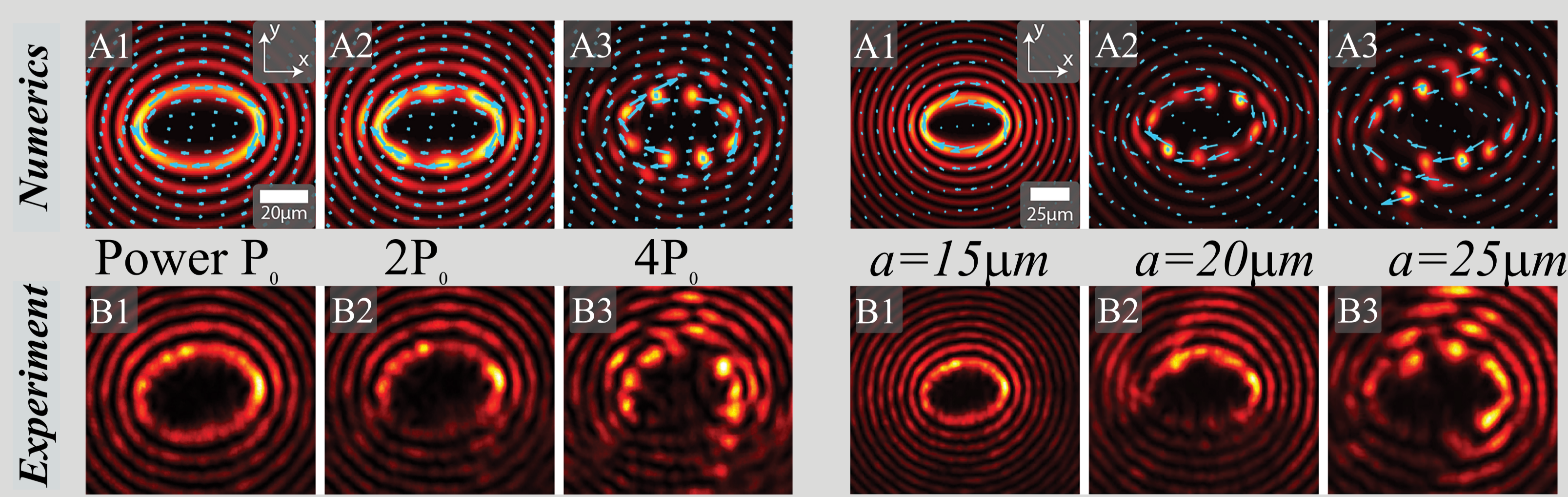


Fig. 7. Transverse intensity distribution of elliptic MB ($a=15\mu\text{m}$) at the back face of the SBN crystal, nonlinearly inscribed with increasing beam powers ($P_0=20\mu\text{W}$).

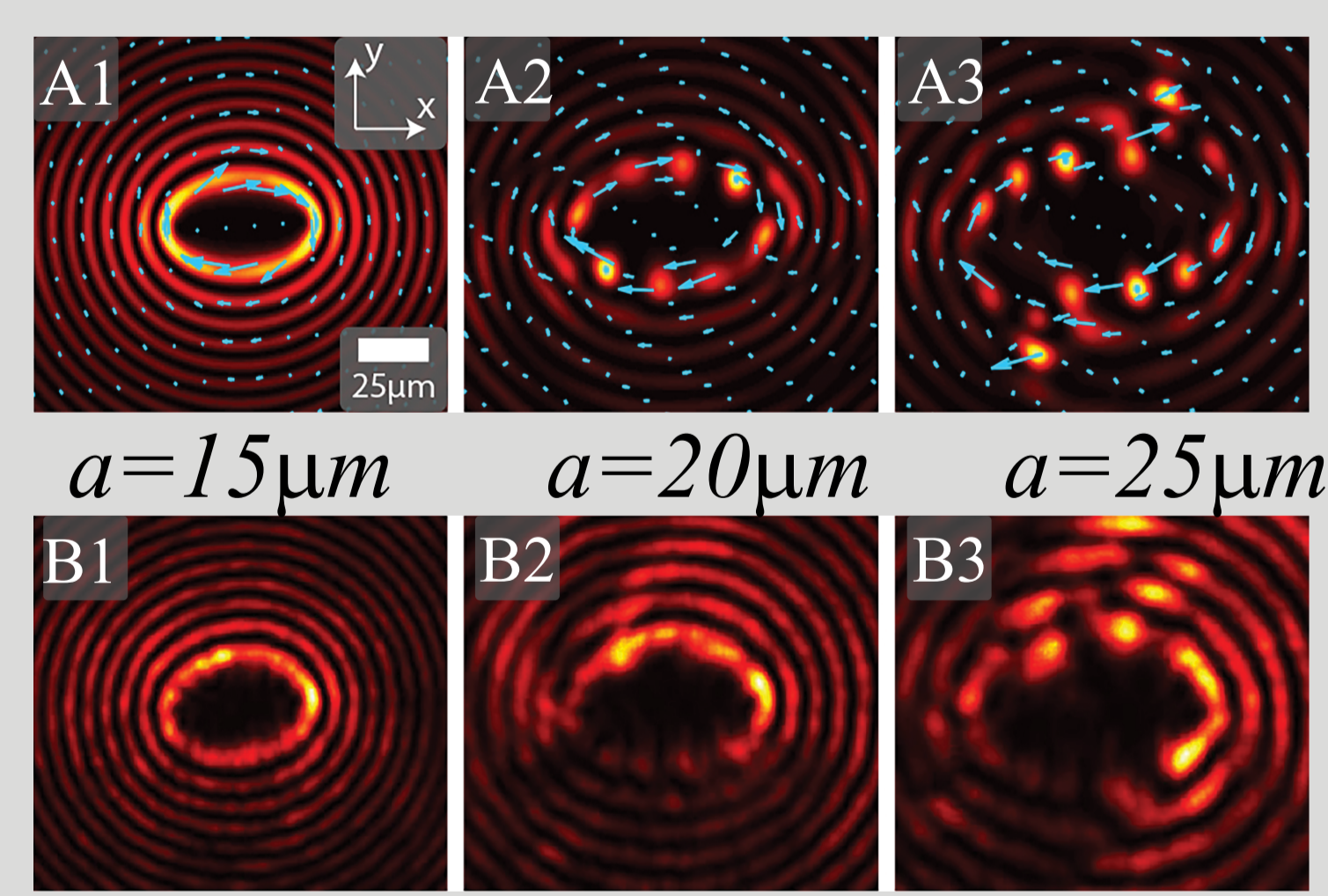


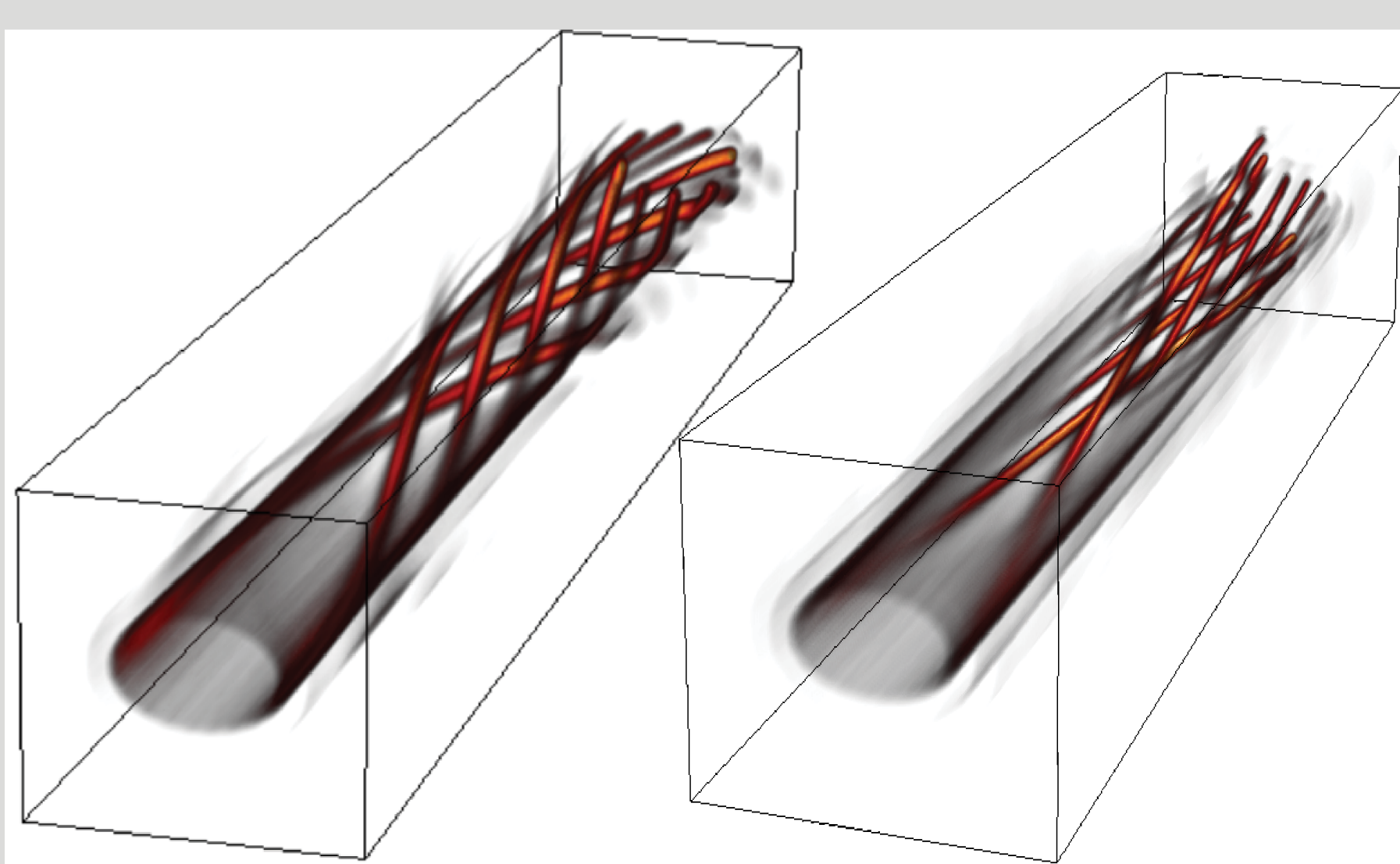
Fig. 8. Transverse intensity distribution at the back face of the SBN crystal after nonlinear propagation of elliptic MB (P_0), for beams with different structure size a .

Chiral lattices

The nonlinear self-action of elliptic MB leads to the formation of high-intensity filaments.

Filaments are rotating in the direction determined by the energy flow.

These twisted refractive index formation could act as chiral waveguides.



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